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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 1762

Application No.: 10/800,717

Examiner: R. LAFOND

Filed: March 16, 2004

Docket No.: 119113

For: METHOD OF MANUFACTURING CERAMIC FILM AND PRESSURE HEAT  
TREATMENT DEVICE USED THEREFOR

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the September 10, 2007 Restriction Requirement, Applicants provisionally  
elect Group I, claims 1-6, without traverse.

Respectfully submitted,

James A. Oliff  
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Registration No. 51,122

JAO:RAC/eks

Date: October 10, 2007

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